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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant(s): **Seutter et al.**

Case: **5192/ISM/CORE MCVD/SB**

Serial No.: **09/776,329**

Filed: **February 2, 2001**

Group Art Unit: **Not yet assigned**

Title: **FORMATION OF A TANTALUM-NITRIDE LAYER**

THE COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D. C. 20231

S I R:

Disclosure Statement under 37 CFR 1.56 and 1.98

Pursuant to 37 CFR 1.56, the documents (copies enclosed) listed on form PTO-1449, submitted herewith, are disclosed. Under rule 37 C.F.R. 1.98(a), the applicants submit that no specific comments are necessary for any of the cited foreign language publications having an enclosed English language translation or abstract.

Respectfully submitted,

3/9/01
Date

By: Patricia A. Verlagieri
Patricia A. Verlagieri, Attorney
Reg. No. 42,201
(732) 530-9404

Thomason, Moser & Patterson, LLP
595 Shrewsbury Avenue, 1st Floor
Shrewsbury, New Jersey 07702

CERTIFICATE OF MAILING under 37 C.F.R. 1.8(a)

I hereby certify that this correspondence is being deposited on MARCH 9 2001 with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Carol Hulson
Signature

3-9-01
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